

INFORMATION DISCLOSURE CITATION IN AN APPLICATION						Attorney Docket No.: 8006-1032			Application No.: 10/576,112		
						Applicant: Akira UEMATSU					
						Filing Date: August 21, 2006			Group Art Unit: 2617		
U.S. PATENT DOCUMENTS											
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)					
	2004/0059689	2004-03-25	MUHONEN et al.								
	2004/0054598	2004-03-18	KALL et al.								
	7,418,256	2008-08-26	KALL et al.								
FOREIGN PATENT DOCUMENTS											
Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation					
						Yes	No				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)											
		Chinese Office Action in the corresponding Chinese patent application 200480037545.4, issued on October 24, 2008									

EXAMINER: /Kuo-kong Woo/	DATE CONSIDERED 07/07/2009
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

* Abstract provided for the Examiner's convenience

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.W./